



PATENT  
8001-1190

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Tatsuya USAMI

Conf. 4182

Application No. 10/766,886

Group 2811

Filed January 30, 2004

Examiner Nitin Parekh

SEMICONDUCTOR DEVICE HAVING COPPER DAMASCENE  
INTERCONNECTION AND FABRICATING METHOD THEREOF

AMENDMENT

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 13, 2005

Sir:

In response to the Office Action mailed April 13, 2005,  
for which the period for response has been extended three months,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims which begins on page 2 of this paper.

**Remarks** begin on page 10 of this paper.